



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Frank Y. Xu et al.

App. No.: 10/784,911 GPAU: 1713

Filing Date: 02/23/2004 Examiner: Satya B. Sastri

Dkt. No.: PA115-57-03 Conf. No.: 6149

For: MATERIALS FOR IMPRINT LITHOGRAPHY

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to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

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Date: 11/19/04

Respectfully Submitted,



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| Sheet | 1 | of | 20 | Attorney Docket Number | PA115-57-03 |
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| Examiner Name | Satya B. Sastri |

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| Sheet | 6 | of | 20 | Attorney Docket Number | PA115-57-03 |
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| Application Number | 10/784,911 |
| Filing Date | 02/23/2004 |
| First Named Inventor | Xu et al. |
| Group Art Unit | 1713 |
| Examiner Name | Satya B. Sastri |

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| Application Number | 10/784,911 |
| Filing Date | 02/23/2004 |
| First Named Inventor | Xu et al. |
| Group Art Unit | 1713 |
| Examiner Name | Satya B. Sastri |
| Attorney Docket Number | PA115-57-03 |

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Application Number 10/784,911**Filing Date** 02/23/2004**First Named Inventor** Xu et al.**Group Art Unit** 1713**Examiner Name** Satya B. Sastri**Attorney Docket Number** PA115-57-03**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

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| Application Number | 10/784,911 |
| Filing Date | 02/23/2004 |
| First Named Inventor | Xu et al. |
| Group Art Unit | 1713 |
| Examiner Name | Satya B. Sastri |
| Attorney Docket Number | PA115-57-03 |

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| | | | | Filing Date | 02/23/2004 |
| | | | | First Named Inventor | Xu et al. |
| | | | | Group Art Unit | 1713 |
| | | | | Examiner Name | Satya B. Sastri |
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|--------------------|----------|---|----------------|
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